by certify that this correspondence is being deposited with the U.S. Postal vice with sufficient postage as First Class Mail, in an envelope addressed to: S Non-Fee Amendment, Commissioner for Patents, P.O. Box 1460, Alexandria, VA 22313-1450, on the date shown below.

Dated: January 2, 2004

Signature:

Docket No.: 30205/38088

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Geun Su Lee, et al.

Application No.: 10/080,319

Art Unit: 1752

Examiner: Yvette C. Thornton Filed: February 21, 2002

·For: PHOTORESIST MONOMERS, POLYMERS THEREOF AND PHOTORESIST

COMPOSITION CONTAINING THE SAME

## AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Commissioner:

## **INTRODUCTORY COMMENTS**

Please enter the following amendment in response to the office action mailed on October 2, 2003.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.